IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:		Vladimir Pavlovich POPOV, et al.			
Serial No.: 10/542,12		23	Group No.:	2823	
Filed	Filed: December 9, 2005		Examiner:	Q. Jefferson	
For:	For: METHOD FOR PRODUCING A SILICON-ON-INSULATOR STRUCTURE				
Atto	Attorney Docket No.: U 015850-2				
P. O.	emissioner for Pater . Box 1450 . andria, VA 22313-		TRANSMISSION ((37 CFR 1.8a)	
I hereby certify that this correspondence is, on the date shown below, being:					
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	deposited with the Unit with sufficient postage envelope addressed to Patents, P. O. Box 1450, 1450	as first class mail in an the Commissioner for	Trad	emark Office to (571)-273-8300	
	Signature				
Date:	March 26, 2008				

(type or print name of person certifying)